

Our Ref.: 3008-0034
File No.: 521.41463X00
Client Ref.: PHCF-01103

PATENT

#17/c
118/04

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Application of :
Oka, et al. :
Application S/N 09/925,626 : Art Unit: 2811
Filed: August 10, 2001 : Examiner: Shouxiang Hu

For: CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE,
CRYSTALLINE SILICON FILM PHOTOVOLTAIC DEVICE, AND PROCESS FOR
PRODUCING CRYSTALLINE SILICON THIN FILM SEMICONDUCTOR DEVICE

PRELIMINARY AMENDMENT

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application, prior to examination thereof,
as follows:

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DEC - 2 2003
TECHNOLOGY CENTER 2800